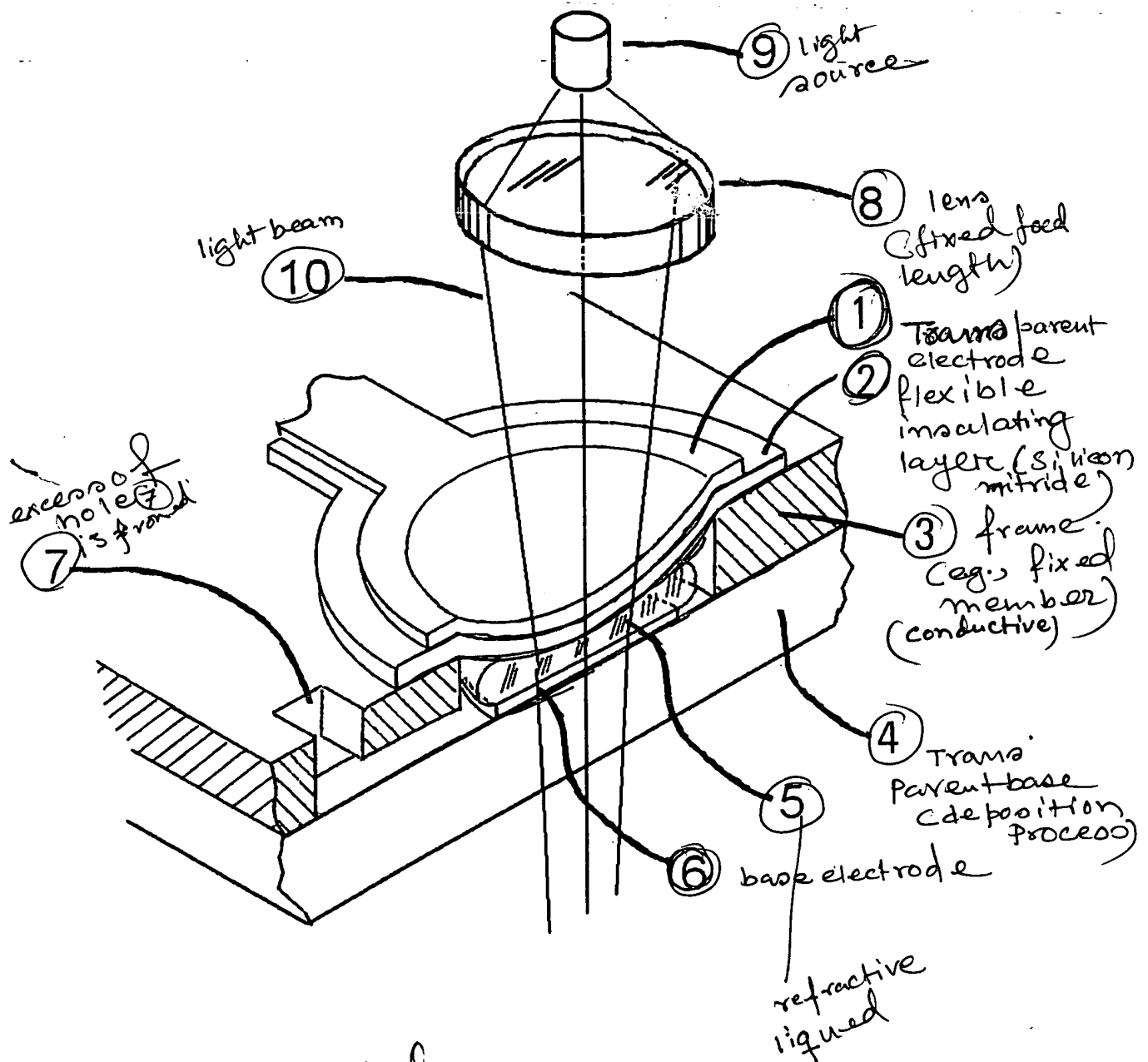


359 / 64a



micro-electromechanical
micro-mirror device

FIG 1

transparent flat —
transparent membrane —
to combine and to create
adaptive lens.

electrostatic force
onto silicon substrate —

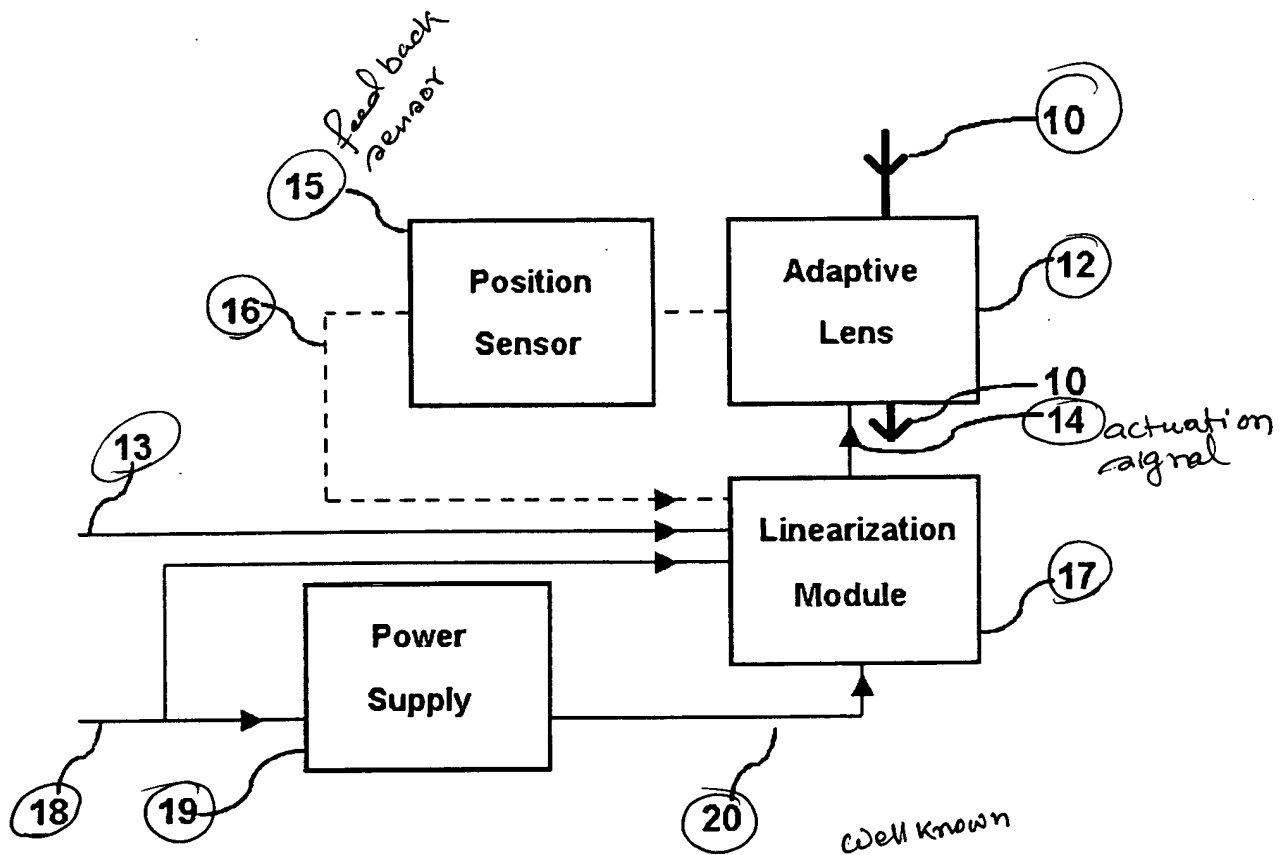
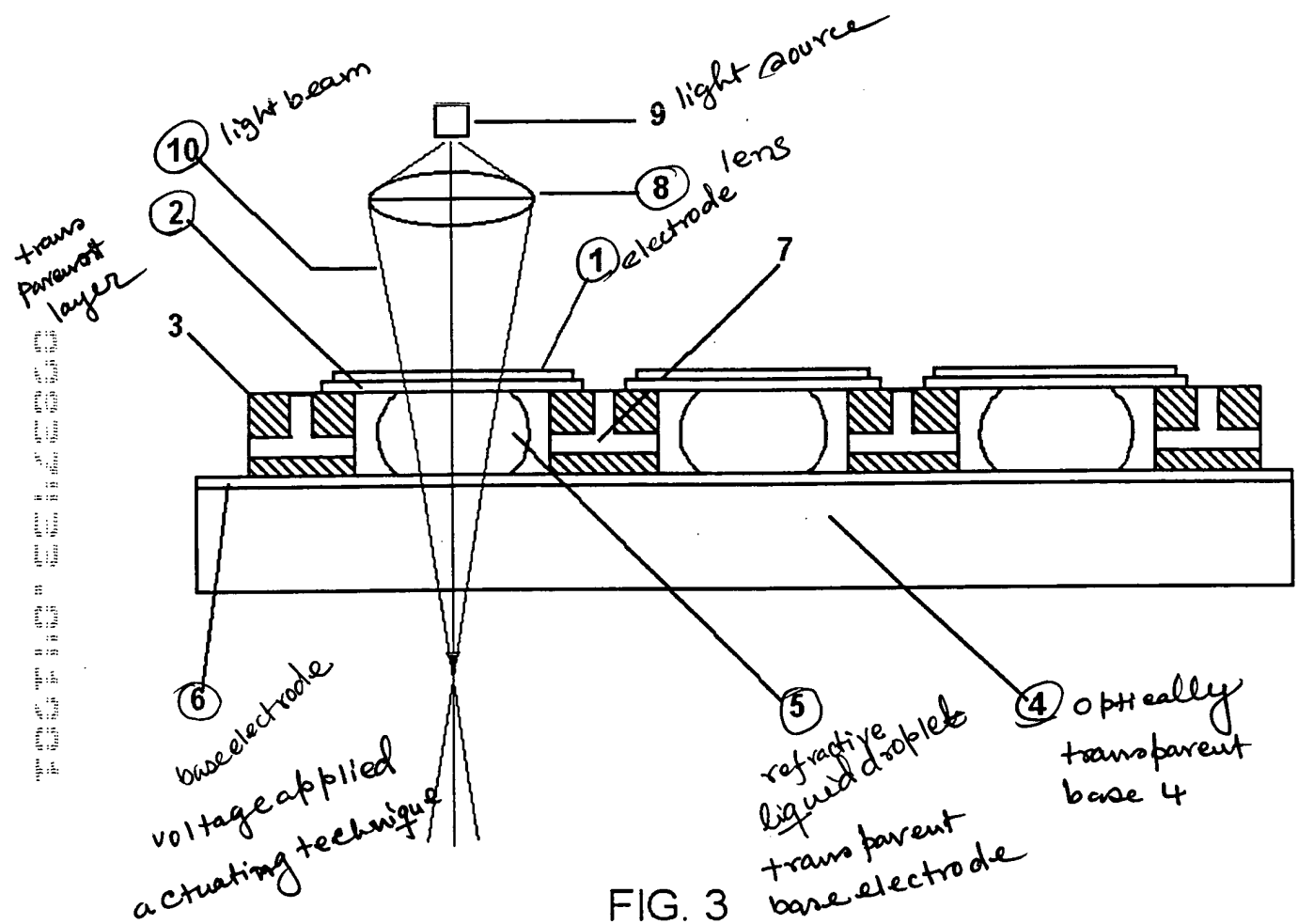


FIG.2



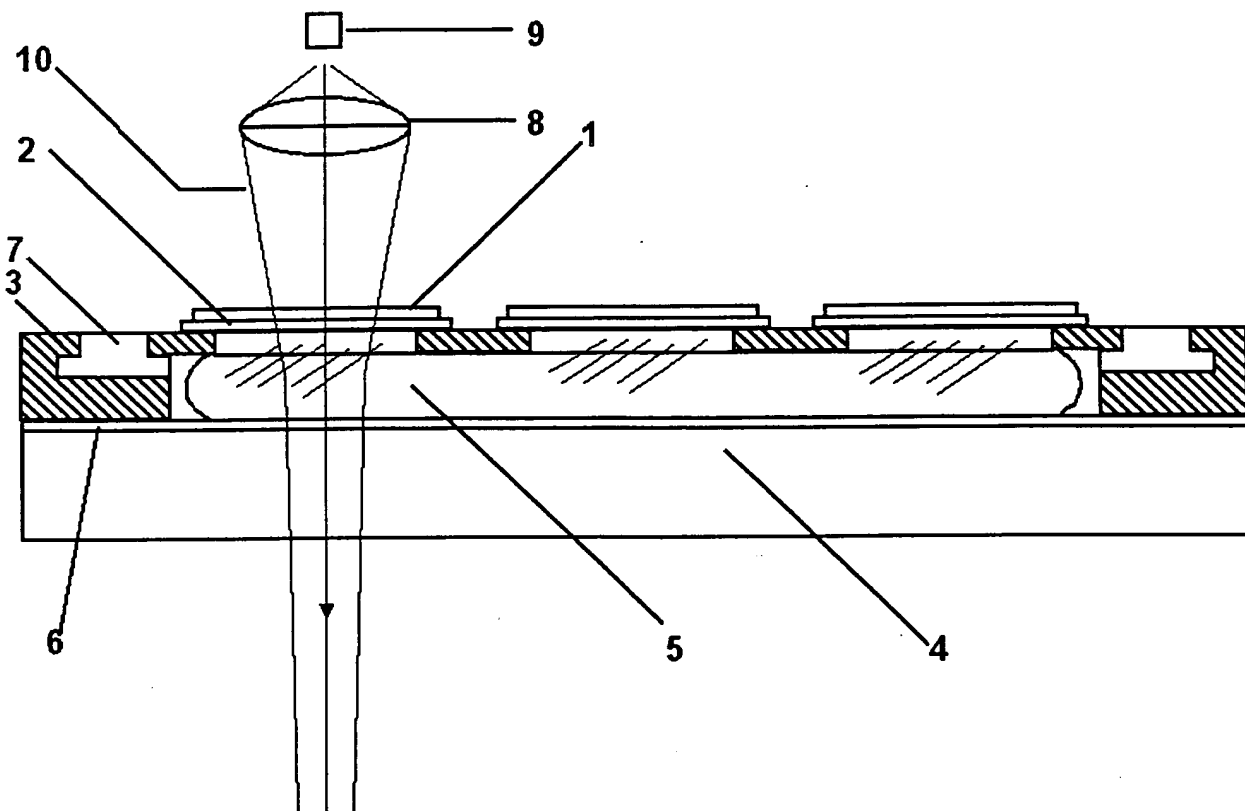


FIG. 4